



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2814

PATENT APPLICATION
Do. No. 4591-170
Client No. IE10189-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jong-Ho LEE and Nae-In LEE

Serial No. 09/776,059 Examiner: Wille, Douglas A

Confirmation No. 9369

Filed: February 2, 2001 Group Art Unit: 2814

For: DIELECTRIC LAYER FOR SEMICONDUCTOR DEVICE AND
METHOD OF MANUFACTURING THE SAME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the Final Office Action, Paper No. 0604, dated June 8, 2004, please
amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.

08/03/2004 CCHAU1 00000095 131703 09776059

01 FC:1202 162.00 DA
02 FC:1201 86.00 DA

OK to
enter
D file
11 Aug 04